

Notice of References Cited

Application/Control No. 09/470,650	Applicant(s)/Patent Under Reexamination FIGURA ET AL.		
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Lisa A Kilday	2829	Page 1 of 1	

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-			
	В	US-			
	6	US-			
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	Е	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"A comparison of HDP oxide and Spin-On polymer for Intermetal dielectric applications in sub-half micron devices", Zheng et al., DUMIC conferencepp. 283-293 (pages 288, 290, and 292 are blank), 2/10/97
	٧	"Diagnostic Investigation of Oxide etching in a commercial high-density plasma etcher", John Arnold, The American Physical Society, 10/21/96.
	w	
	х	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.